

Atty. Docket No.042390.P4220

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

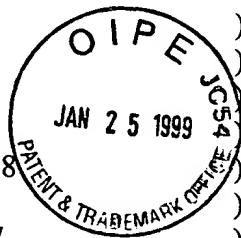
Mark T. Bohr

Application No. 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION  
STRUCTURE AND METHOD  
OF FABRICATION

Asst. Commissioner for Patents  
Washington, D.C. 20231



Examiner: Oh, E.

Art Unit: 2822

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PRELIMINARY AMENDMENT

Sir:

Prior to examination of this application, Applicant respectfully requests that the Examiner enter the following amendment.

IN THE CLAIMS

Please cancel Group I claims, claims 21-30, drawn to a semiconductor device, before calculating the filing fee for the present application. Applicant request to prosecute Group II claims, claims 1-20, drawn to a process of making a semiconductor device apparatus.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

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FEB 01 1999

GROUP 2100

Date: 1/19, 1999

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